$\underline{D} \,\underline{E} \,\underline{C} \,\underline{L} \,\underline{A} \,\underline{R} \,\underline{A} \,\underline{T} \,\underline{I} \,\underline{O} \,\underline{N}$

As the below named inventors, we hereby declare that:

X is attached hereto.

(Application Serial No.)

Our residence, post office address and citizenship are as stated below next to our names.

We believe we are the original, first and joint inventors of the subject matter which is claimed and for which a patent is sought on the invention entitled "METHOD AND SYSTEM FOR MONITORING PLASMA USING OPTICAL EMISSION SPECTROMETRY," the specification of which:

was fi	led on	as Application Serial No.:	
We hereby state identified specification,		wed and understand the	contents of the above
known to us to be mate	rial to patentability of	the Patent and Trademar the subject matter claime ederal Regulations, § 1.56.	d in this application, as
any foreign application	e(s) for patent or inverging application for pa	fits under Title 35, United entor's certificate listed tent or inventor's certificate is claimed:	below and have also
	PRIOR FOREIGN	N APPLICATION(S)	
			Priority Claimed
(Number)	(Country)	(Date Filed)	Yes/No
(Number)	(Country)	(Date Filed)	Yes/No
We hereby claim the benefit under Title 35, United States Code, § 120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, § 112, we acknowledge the duty to disclose all information known to us to be material to patentability of the subject matter claimed in this application, as "materiality" is defined in Title 37, Code of Federal Regulations, § 1.56, which become available between the filing date of the prior application and the national or PCT international filing date of this application:			

(Filing Date)

(Status)

We hereby direct that all correspondence and telephone calls be addressed to **Michael G. Fletcher**, Fletcher Yoder, P.O. Box 692289, Houston, Texas 77269-2289, (281) 970-4545.

We hereby declare that all statements made of our own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Inventor's Full

Name:	Neal	R.	Rueger		
	(First)	(Initial)	(Last)		
Inventor' s Signature:	Neal	R. Rueger			
Date: <u>9/3</u>	0/03	Country of Citizenship	USA		
Residence Address:	1306 Broxon Street, Boise, ID 83705, U.S.A.				
	(Include n	umber, street name, city, state, a	nd country)		
Post Office Address:	Same as above.				
(If different)					
		5. s			
		•	•		
Inventor's Full					
Name:	Kevin	Т.	Hamer		
	(First)	(Initial)	(Last)		
Inventor' s Signature:	·				
Date:		Country of Citizenship	USA		
Residence Address:	3744 W	V. Neimann Drive, Meridian, II	D 83642		
	(Include n	umber, street name, city, state, a	nd country)		
Post Office Address:	Same as above.				
(If different)					

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Inventor's Full

Name:	Neal	R	Rueger	
	(First)	(Initial)	(Last)	
Inventor' s Signature:				
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Residence Address:	1306 Broxon Street, Boise, ID 83705, U.S.A.			
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Post Office Address:	Same as above.			
(If different)				
Inventor' s Full				
Name:	Kevin	Т.	Hamer	
	(First)	(Initial)	(Last)	
Inventor' s Signature:	Mr. J. Not	m		
Date: /0/01/	03	Country of Citizenship	USA	
Residence Address:	3744 W. N	Neimann Drive, Meridian, ID	83642	
		ber, street name, city, state, ar	·	
Post Office Address:	Same as above.			
(If different)				

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Ap	plication of:	§		
	Neal R. Rueger et al.	§	Group Art Unit:	Unassigned
Serial N	o.: Unassigned	8 §		
		§	Examiner:	Unassigned
Filed:	Unassigned	§		
		§		
For:	METHOD AND SYSTEM FOR MONITORING	§	Atty Docket:	MICS:0113
	PLASMA USING OPTICAL EMISSION SPECTROMETRY	§		02-1533

ELECTION UNDER 37 C.F.R. §§ 3.71 AND 3.73 AND POWER OF ATTORNEY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned, being Assignee of the entire interest in the above-identified application by virtue of an Assignment recorded in the United States Patent and Trademark Office as set forth below, hereby elects, under 37 C.F.R. § 3.71, to prosecute the application to the exclusion of the inventor(s).

The Assignee hereby revokes any previous Powers of Attorney and appoints:

Michael L. Lynch, Reg. No. 30,871; and Charles Brantley, Reg. No. 38,086

of MICRON TECHNOLOGY, INC.; and also

Michael G. Fletcher, Reg. No. 32,777; Patrick S. Yoder, Reg. No. 37,479; Barry D. Blount, Reg. No. 35,069; Ralph A. Graham, Reg. No. 47, 607; Robert A. Manware, Reg. No. 48,758; Tait R. Swanson, Reg. No. 48,226; John M. Rariden, Reg. No. 54,388; Brent R. Knight, Reg. No. 54,226; and Manish B. Vyas, Reg. No. 54,516

with the law firm of FLETCHER YODER, as its attorneys with full power of substitution and revocation, to prosecute the application, to make alterations and amendments therein, to transact all business in the Patent and Trademark Office in connection therewith, to receive any Letters Patent, and for one year after issuance of such Letters Patent to file any request for a certificate of correction that may be deemed appropriate.

Pursuant to 37 C.F.R. § 3.73, the undersigned has reviewed the evidentiary documents, specifically the Assignment to MICRON TECHNOLOGY, INC. referenced below, and certifies that to the best of my knowledge and belief, title remains in the name of the Assignee.

Please direct all communications as follows:

Michael G. Fletcher FLETCHER YODER P.O. Box 692289 Houston, TX 77269-2289 (281) 970-4545

ASSIGNEE: Micron Technology, Inc.

Date:		By: A
ASSIGNMENT:		Name: Michael L. Lynch, Chief Patent Counsel
ASSIGNMENT:		
X Enclosed for recording		
Previously recorded:	Date:	
	Reel:	
	Frame:	